Preliminary Amendment

Applicant: Thomas Hecht et al.

Serial No.: Unknown

(Priority Application No. DE 102 45 537.6) (International Application No. PCT/DE03/03188)

Filed: Herewith

(Priority Date: September 30, 2002)

(International Filing Date: September 24, 2003)

Docket No.: I433.153.101/13.555

Title: METHOD AND PROCESS REACTOR FOR SEQUENTIAL GAS PHASE DEPOSITION BY MEANS

OF A PROCESS CHAMBER AND AN AUXILIARY CHAMBER (As Amended)

IN THE TITLE

Please replace the title with the following rewritten title:

METHOD AND PROCESS REACTOR FOR SEQUENTIAL GAS PHASE
DEPOSITION BY MEANS OF A PROCESS CHAMBER AND AN AUXILIARY
CHAMBER

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IN THE SPECIFICATION

Please insert the following paragraph beginning at page 1, line 6, of the substitute specification with the following paragraph:

Cross Reference to Related Application

This Utility Patent Application claims the benefit of the filing date of German Application No. DE 102 45 537.6, filed September 30, 2002, and International Application No. PCT/DE03/03188, filed September 24, 2003, both of which are herein incorporated by reference.